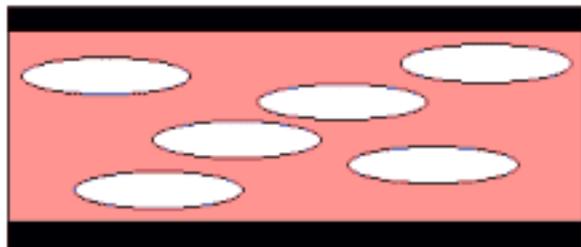


Piezoelectricity

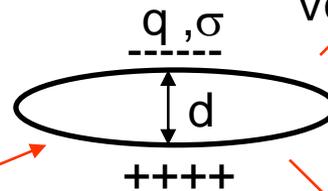
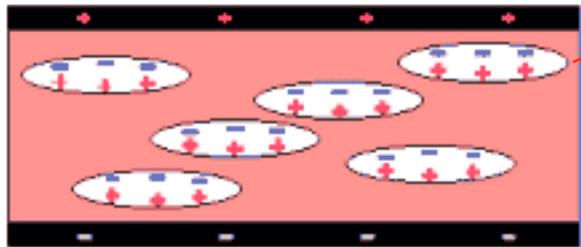
Material from

- 3.6 Piezoelectric effect
- 8.4 Piezoelectric accelerometer
- Appendix A
- Extra material on porous polypropylene

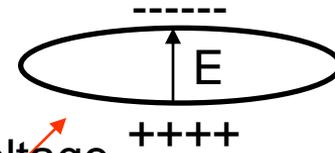
Porous polypropylene



corona charging



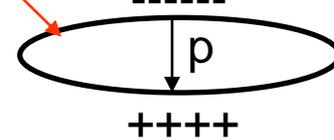
Voltage



$$E = \frac{\sigma}{\epsilon_0}$$

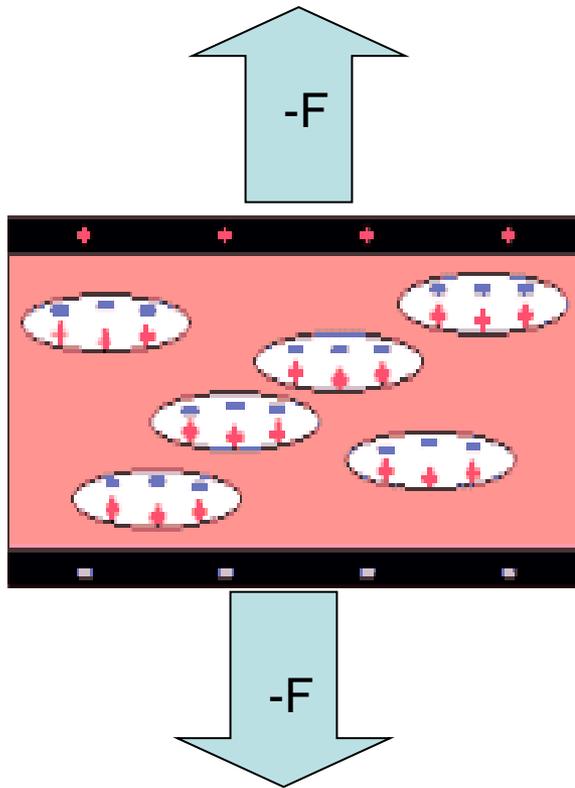
$$V = \frac{\sigma}{\epsilon_0} d$$

Polarization/dipoles

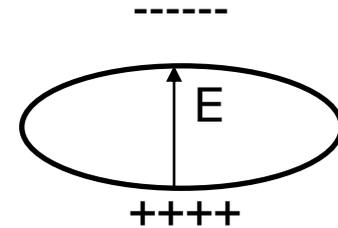


$$p = dq$$

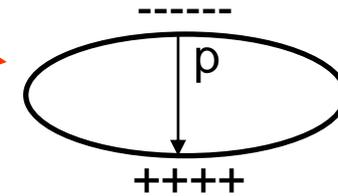
Effect of tension



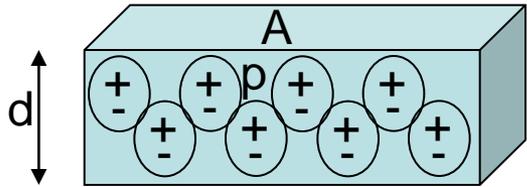
Increased
voltage



Increased
polarization



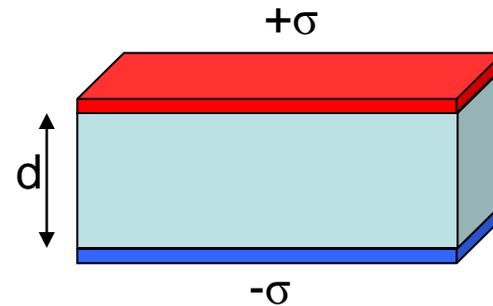
Polarisasjonstetthet/ overflateladning



p : dipolmoment/volumenhet

Totalt dipolmoment:

$$P = pV = pAd$$



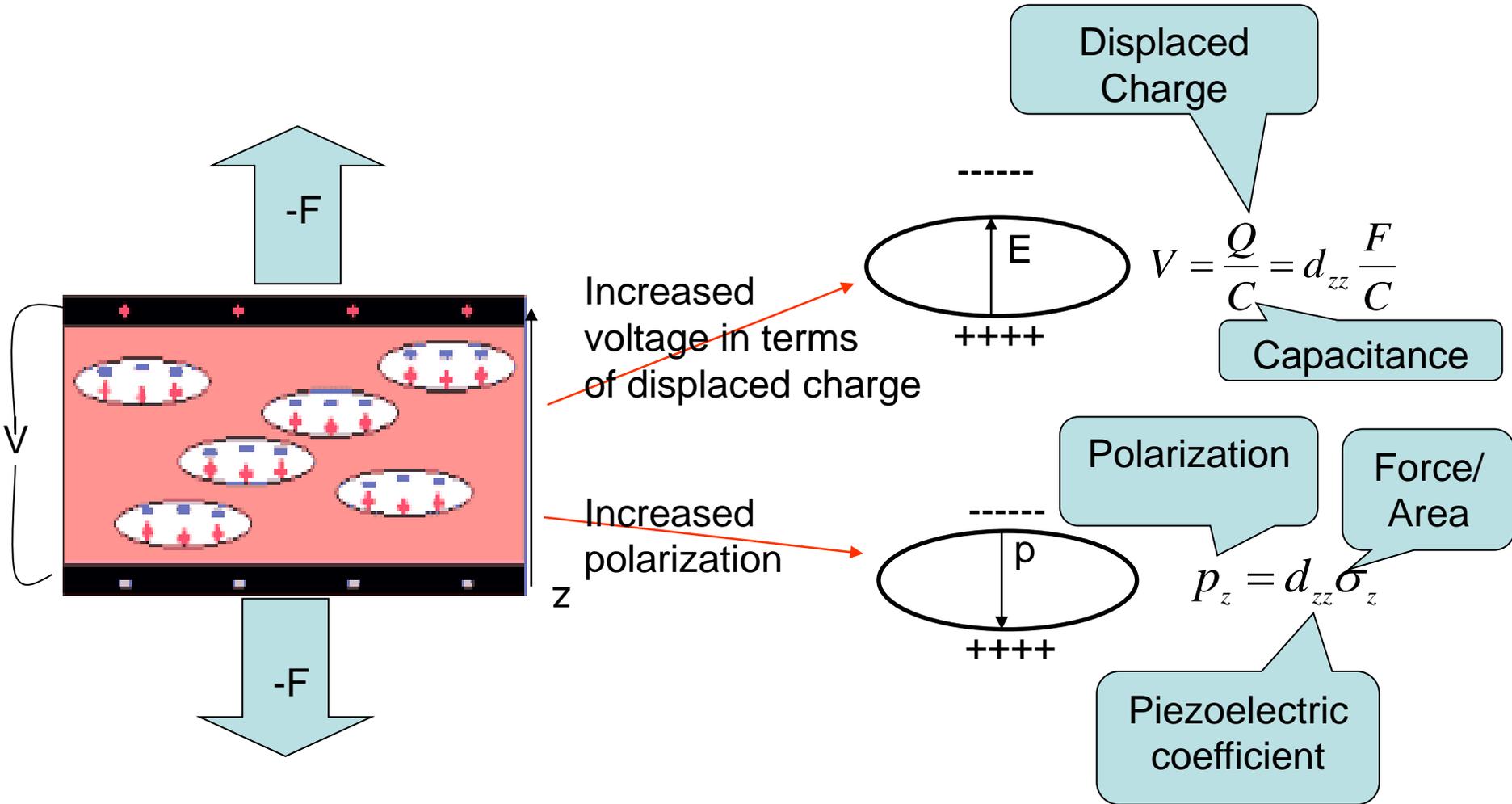
σ : flateladning ($Q = \sigma A$)

Totalt dipolmoment:

$$P = Qd = \sigma Ad$$

$$p = \sigma$$

Piezoelectric coefficient



Quartz (SiO_2)

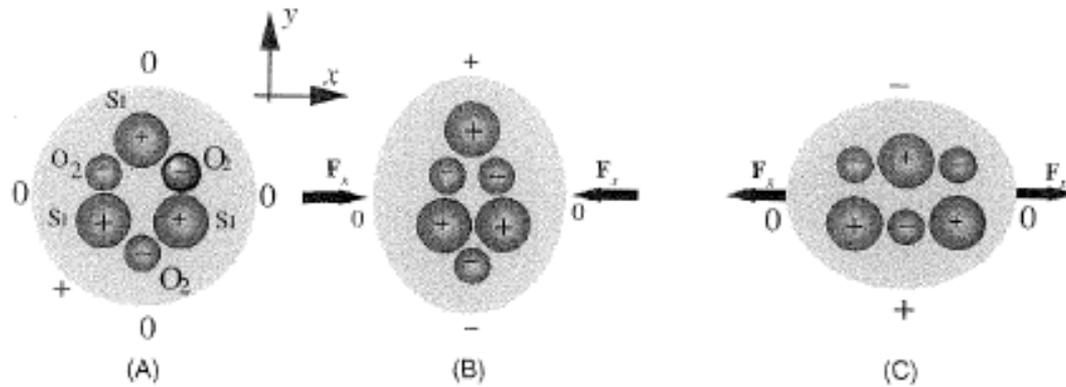
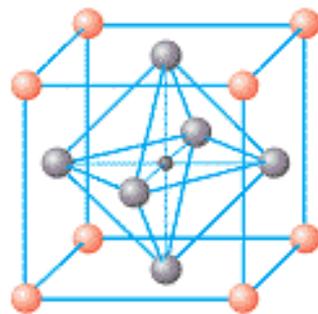


Fig. 3.21. Piezoelectric effect in a quartz crystal.

PZT

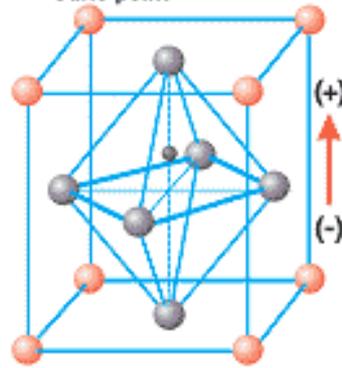
Figure 1.1 Crystal structure of a traditional piezoelectric ceramic

(a) temperatures above Curie point



cubic lattice, symmetric arrangement of positive and negative charges

(b) temperatures below Curie point

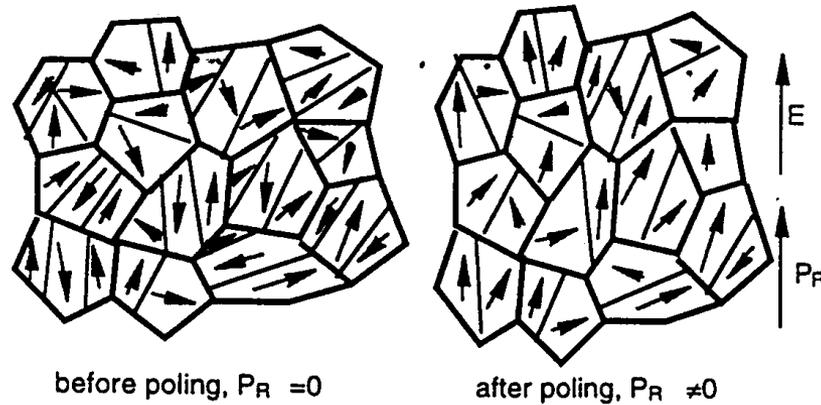
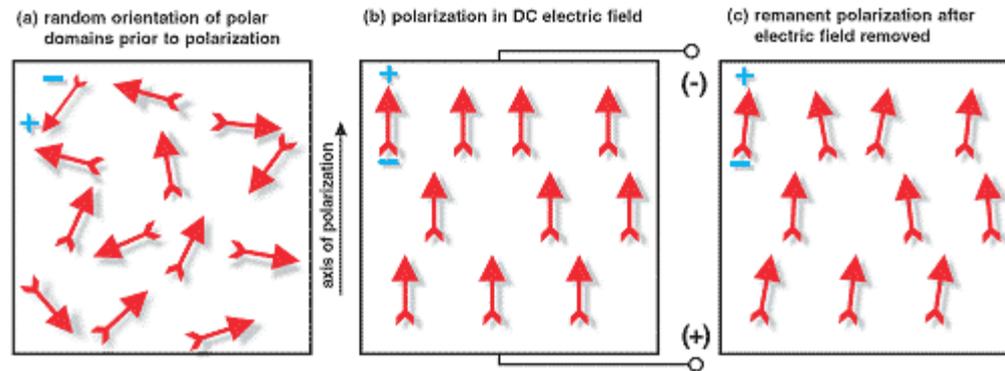


tetragonal (orthorhombic) lattice, crystal has electric dipole

- A^{2+} = Pb, Ba, other large, divalent metal ion
- O^{2-} = oxygen
- B^{4+} = Ti, Zr, other smaller, tetravalent metal ion

Poling

Figure 1.2 Polarizing (poling) a piezoelectric ceramic*



PVDF

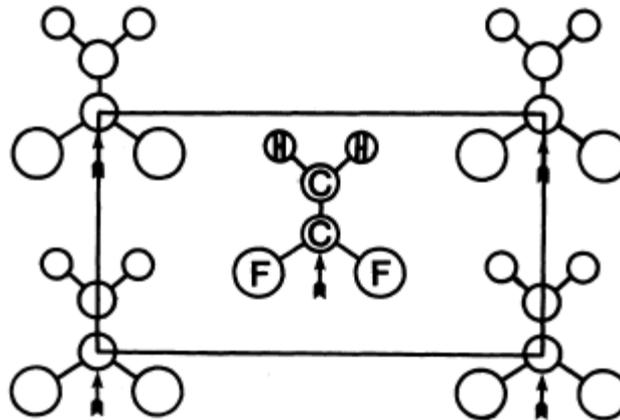
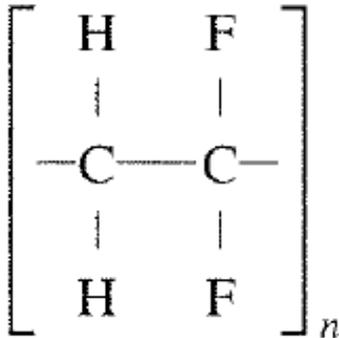


Fig. 1—Relative positions of atoms in poly(vinylidene fluoride) in all-trans conformation when viewed parallel to the chain axis and relative positions of chains in the unit cell of β crystal phase when projected onto the ab plane. Arrow indicates net dipole moment perpendicular to chain axis.

Piezoelectric accelerometer

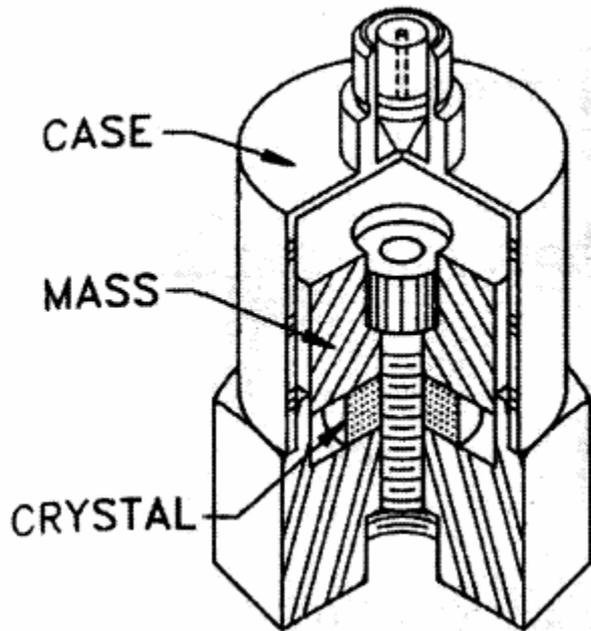


Fig. 8.6. Basic schematic of a piezoelectric accelerometer. Acceleration of the case moves it relative to the mass, which exerts a force on the crystal. The output is directly proportional to the acceleration or vibration level.

Piezoelectric tensor

$$\mathbf{P}_{xx} = d_{11}\sigma_{xx} + d_{12}\sigma_{yy} + d_{13}\sigma_{zz},$$

$$\mathbf{P}_{yy} = d_{21}\sigma_{xx} + d_{22}\sigma_{yy} + d_{23}\sigma_{zz},$$

$$\mathbf{P}_{zz} = d_{31}\sigma_{xx} + d_{32}\sigma_{yy} + d_{33}\sigma_{zz},$$

(3.65)

Bending mode

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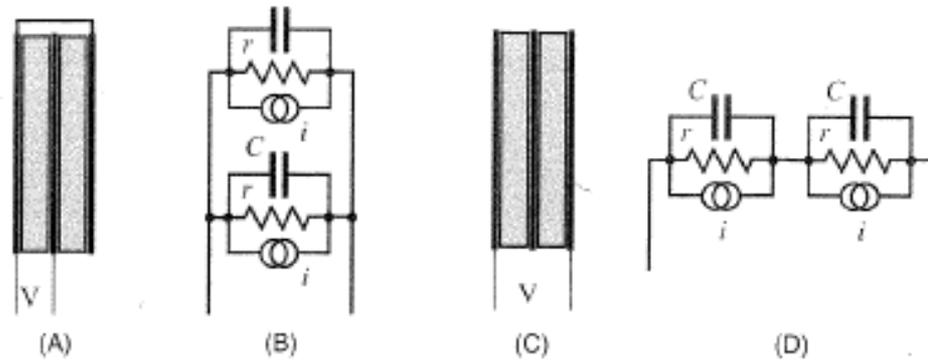


Fig. 3.24. Laminated two-layer piezoelectric sensor.

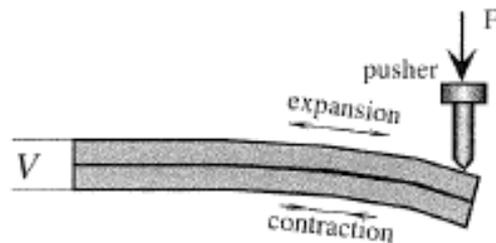
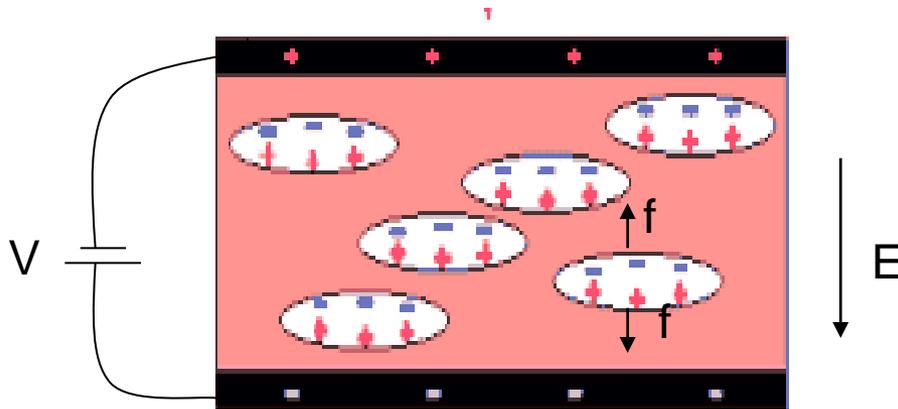


Fig. 3.25. Parallel (A) and serial (C) laminated piezoelectric sensors and their corresponding equivalent circuits (B and D).

The converse effect (electro->piezo)



Material Parameters

Table A.8. Properties of Piezoelectric Materials at 20°C

	PVDF	BaTiO ₃	PZT	Quartz	TGS
Density ($\times 10^3$ kg/m ³)	1.78	5.7	7.5	2.65	1.69
Dielectric constant, ϵ_r	12	1700	1200	4.5	45
Elastic modulus (10^{10} N/m)	0.3	11	8.3	7.7	3
Piezoelectric constant (pC/N)	$d_{31} = 20$				
	$d_{32} = 2$	78	110	2.3	25
	$d_{33} = -30$				
Pyroelectric constant (10^{-4} C/m ² K)	4	20	27	—	30
Electromechanical coupling constant (%)	11	21	30	10	—
Acoustic impedance (10^6 kg/m ² s)	2.3	25	25	14.3	—